



IPW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Radecker Docket No.: INF-141
Serial No.: 10/798,863 Art Unit: 2811
Filed: March 12, 2004 Examiner: TBD
For: Insulator Structure and Method for Producing Insulator Structures in a Semiconductor Substrate

Certificate of Mailing via First Class Mail (37 C.F.R. § 1.8(a))

Date of Deposit: August 2, 2004

I hereby certify that the below listed correspondence is being deposited with the United States Postal Service on the date indicated above as first class mail in an envelope addressed to: Mail Stop: Missing Parts, Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450.

Certificate of Mailing via First Class Mail (1 page)
Information Disclosure Statement (1 page)
IDS Form PTO/SB/08a (1 page) citing (5) references
Copies of (2) cited references
Transmittal of Certified Copy of Priority Document (1 page)
Certified Copy of German Patent Application 103 11 312.6
Return Postcard

Respectfully submitted,

Natalie Swider
Legal Assistant

Slater & Matsil, L.L.P.
17950 Preston Rd., Suite 1000
Dallas, TX 75252
Tel: 972-732-1001
Fax: 972-732-9218